Electronic Pate	nt App	lication Fee	Transm	ittal			
Application Number:	10	10572353					
Filing Date:	05-	05-Jan-2007					
Title of Invention:	Mie	Microlithography method using a mask with curved surface					
First Named Inventor/Applicant Name:	Jea	Jean-Charles Guibert					
Filer:	Ma	Marvin Jay Spivak/Maritza Ulloa					
Attorney Docket Number:	28	287990US2PCT					
Filed as Large Entity	•						
U.S. National Stage under 35 USC 371 Fil	ling Fee	s					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:					1		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 2 months with \$0 paid		1252	1	490	490		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			490